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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Daniel KOPF et al.

Application No.: 10/581,893

Filed: June 6, 2006

Docket No.: 120391

For: HIGHLY REPETITIVE LASER SYSTEM HAVING A COMPACT DESIGN

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.



1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.

Respectfully submitted,

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Sheet 1 of 1

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 120391	APPLICATION NO. 10/581,893
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)		APPLICANT(S) Daniel KOPF et al.			
				FILING DATE June 6, 2006	GROUP
U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number	Date	Name	
FOREIGN PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract
	1	WO 2004/107514 A2	12/9/2004	WIPO	X
OTHER DOCUMENTS					
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)			
	2	Gloster, L.A.W. et al., "Diode-pumped Q-switched Yb:S-FAP laser," Optics Communications Vol. 146, pp 177-180, (1998).			
	3	Kruger, E., "High-repetition-rate electro-optic cavity dumping," Rev. Sci. Intrum. Vol. 66, pp 961-967, February 1995.			
	4	Krausz, Ferenc et al., "Femtosecond Solid-State Lasers," IEEE Journal of Quantum Electronics, Vol. 28, No. 10, pp 2097-2122, October 1992.			
	5	Kubecek, Vaclav et al., "Practical source of 50 ps pulses using a flashlamp pumped Nd:YAG laser and passive all-solid-state pulse control," Optics Communications Vol. 177, pp 317-321, (2000).			
	6	Paschotta, R. et al., "Passive mode locking with slow saturable absorbers," Applied Physics B, Vol. 73, pp 653-662, (2001).			
	7	Ramaswamy, M. et al., "Cavity-dumped femtosecond Kerr-lens mode-locked Ti:Al203 laser," Optics Letters, Vol. 18, No. 21, November 1, 1993.			
	8	Baltuska, A. et al., "All-solid-state cavity-dumped sub-5-fs laser," Applied Physics B, Vol. 65, pp 175-188, 1997.			
EXAMINER					DATE CONSIDERED
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.					